



JFw

Our Ref. No.: 42390P4214DC

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application for:

**Chunlin Liang, Brian S. Doyle**

Serial No.: 10/632,578

Filed: July 31, 2003

For: **A THERMAL CONDUCTING  
TRENCH IN A SEMICONDUCTOR  
STRUCTURE AND METHOD FOR  
FORMING THE SAME**

Examiner: Thanh V. Pham

Art Group: 2823

Confirmation No. 5026

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

Mail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Dear Examiner:

In response to the Office Action dated June 28, 2004, Applicants respectfully request entry of the amendment set forth below and consideration of the remarks that follow.